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| Search Notes | Application/Control No. | Applicant(s)/Patent Under Reexamination |
| | 09605293 | CHAPEK, DAVID L. |
|  | Examiner | Art Unit |
| | Jay C Kim | 2815 |

SEARCHED

| Class | Subclass | Date | Examiner |
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| 257 | E21.489, E21.491, E21.212 | 9/12/08 | J.K. |
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SEARCH NOTES

| Search Notes | Date | Examiner |
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| EAST (US-PGPUB; USPAT; USOCR), See EAST Search History | 9/12/08 | J.K. |

INTERFERENCE SEARCH

| Class | Subclass | Date | Examiner |
|--------------|-----------------|-------------|-----------------|
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